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SERIAL NUMBER 10/706,266	FILING DATE 11/13/2003  RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 061063-0306825
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P2002-336690 11/20/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/24/2004

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 4	TOTAL  CLAIMS 24	INDEPENDENT  CLAIMS 1
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

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## TITLE

Silicon wafer and manufacturing method thereof

FILING FEE  RECEIVED 1102	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/>
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